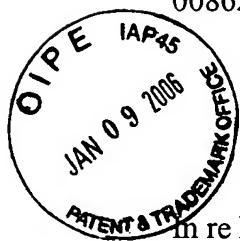


*Co/C*

00862.023258

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent of:

Yuichi IWASAKI et al.	)	Examiner: P. M. Gurzo
Application No.: 10/670,328	)	Group Art Unit: 2881
Filed: September 26, 2003	)	
For: DEFLECTOR, METHOD OF MANUFACTURING DEFLECTOR, AND CHARGED PARTICLE BEAM EXPOSURE APPARATUS	)	January 9, 2006
U.S. Patent No. 6,953,938 B2	)	
Issued: October 11, 2005	)	

Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450  
**Attention: Certificate of Correction Branch**

LETTER CALLING ATTENTION TO ERRORS IN PATENT

Sir:

Patentees note the following errors in the above-identified patent:

COLUMN 10:

Line 62, "specifically," should read -- specifically, --.

COLUMN 16:

Line 7, "mask" should read -- mask, --.

*Certificate  
JAN 13 2006  
of Correction*

COLUMN 19:

Line 51, "water," should read -- water. --.

COLUMN 26:

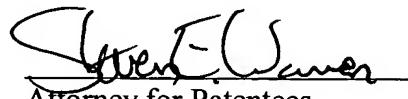
Line 1, "has" should read -- has: --.

These errors are relatively insignificant. Therefore, Patentees believe that filing a Request for Certificate of Correction is not warranted. Rather, Patentees request that this paper be placed of record in the official file of the subject patent.

Patentees believe no fee is due for filing this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fee be deemed required.

Patentees' undersigned attorney may be reached in our Washington, D.C. Office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,



\_\_\_\_\_  
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